

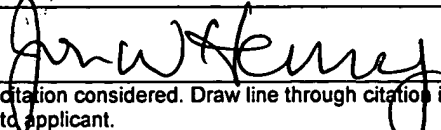
Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 04873-065002	Application No. 09/551,272
		Applicant Yajun Li et al.	
		Filing Date April 18, 2000	Group Art Unit 2873

**Information Disclosure Statement  
by Applicant**  
(Use several sheets if necessary)

(37 CFR §1.98(b))

## U.S. Patent Documents

Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5949577	09/99	Ogata	359	565	
	AB	5745289	04/98	Hamblen	359	569	
	AC	5737120	04/98	Arriola	359	565	
	AD	5734502	03/98	Ebstein	359	565	
	AE	5715091	02/98	Meyers	359	565	
	AF	5706139	01/98	Kelly	359	565	
	AG	5691847	11/97	Chen	359	565	
	AH	5684290	11/97	Arackellian et al.	235	472	
	AI	5684287	11/97	Walts	235	462	
	AJ	5683748	11/97	Gunderson	427	236	
	AK	5646391	07/97	Forbes et al.	235	462	
	AL	5504628	04/96	Borchard	359	558	
	AM	5504350	04/96	Ortyn	257	81	
	AN	5386105	01/95	Quinn et al.	235	462	
	AO	5260828	11/93	Londono et al.	359	569	
	AP	5247162	09/93	Swartz et al.	235	467	
	AQ	5206878	04/93	Sizer, II	372	101	
	AR	5164584	11/92	Wike, Jr. et al.	250	216	
	AS	5144120	09/92	Krichever et al.	235	472	
	AT	5073041	12/91	Rastani	385	33	
	AU	4923281	05/90	Krichever et al.	350	245	
	AV	4836637	06/89	Poorman et al.	350	96.21	
	AW	4820911	04/89	Arackellian et al.	235	467	
	AX	4816600	03/89	Swartz et al.	235	472	
	AY	4676599	06/87	Cruz	350	252	
	AZ	4563056	01/86	Tagawa et al.	350	6.8	
	AAA	4323297	04/82	Kawamura et al.	350	6.8	

Examiner Signature 	Date Considered 6/15/01
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

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U.S. Patent Documents							
Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
<i>JA</i>	ABB	3970781	07/76	Dalton et al.	174	7.6	

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
<i>JA</i>	ACC	60202401	10/85	Japan	—	—		

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	ADD	Gerts, "Micro-optics has macro-potential," Laser Focus World, June 1991
	AEE	Figiward, "Optical properties of conic surfaces," J. Opt. Soc. Am., 52, 287-292 (1962)
	AFF	Goodman, Introduction to Fourier Optics, Table of Contents, pp. 110-120, first ed. 1968, second ed. 1996
	AGG	Johnson et al., "Connectorized Optical Link Package Incorporating a Microlens," Proceedings of the 30 <sup>th</sup> Electronics Components Conference, San Francisco, CA, April 28-30, 1980
	AHH	Tsi et al., "System analysis of CCD-based bar code readers," Appl. Opt., 32, 3504-3512 (1993)
	AII	Behrman et al., "Influence of temperature on diffractive lens performance," Appl. Opt., 32, 2483-2489

Examiner Signature <i>[Signature]</i>	Date Considered 6/15/07
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